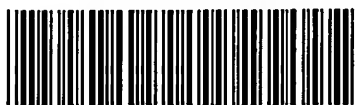


Search Notes

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10/689,182

Examiner

Paul D. Kim

Applicant(s)/Patent under
Reexamination

JENNEKE, RICHARD R.

Art Unit

3729

SEARCHED

Class	Subclass	Date	Examiner
29	603.03- 603.06	7/2/2005	PK
360	294.4-294.7	7/2/2005	PK
	244.8 244.2	↓	
	244 240		
	245.2 245.4		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/966,687 (US PAT. 6,657,821)	7/2/2005	PK
Text Search EAST/NPL (IEEE)	7/2/2005	PK